

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)

Application Number	10767065
Filing Date	2004-01-29
First Named Inventor	Toshiharu Furukawa et al.
Art Unit	2811
Examiner Name	Ori Nadav
Attorney Docket Number	ROC920030268US1

U.S. PATENTS

[Remove](#)

Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Patent citation information please click the Add button.

[Add](#)

U.S. PATENT APPLICATION PUBLICATIONS

[Remove](#)

Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
ON	1	20020163079	A1	2002-11-07	Awano	
ON	2	20030227015	A1	2003-12-11	Choi et al.	

If you wish to add additional U.S. Published Application citation information please click the Add button.

[Add](#)

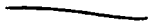
FOREIGN PATENT DOCUMENTS

[Remove](#)

Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² j	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T ⁵
ON	1	1 331 671	EP	A1	2003-07-30	Japan Science and Technology Corporation		<input type="checkbox"/>
ON	2	1 435 660	EP	A2	2004-07-07	Samsung Electronics Co., Ltd.		<input type="checkbox"/>

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10767065
Filing Date	2004-01-29
First Named Inventor	Toshiharu Furukawa et al.
Art Unit	2811
Examiner Name	Ori Nadav
Attorney Docket Number	ROC920030268US1

ON	3	03/0363208	WO	A2	2003-07-31	Fornia Institute of Technology		<input type="checkbox"/>
----	---	------------	----	----	------------	--------------------------------	---	--------------------------

If you wish to add additional Foreign Patent Document citation information please click the Add button

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
ON	1	G.S. DUESBERG ET AL., Ways Towards the Scaleable Integration of Carbon Nanotubes into Silicon Based Technology, Diamond and Related Materials; Elsevier Science Publishers; Amsterdam, NL; Vol. 13, No. 2; February 1, 2004; pages 354-361; XP004492567	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature	ON	Date Considered	7/29/06
--------------------	----	-----------------	---------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.